

# CALL FOR PAPERS



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San Francisco Marriott Hotel  
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**Abstract Deadline: November 1, 1993**

## SYMPOSIA

### A: AMORPHOUS SILICON TECHNOLOGY - 1994

**Eric A. Schiff**, Syracuse University, (315) 443-3908, Fax (315) 443-9103, schiff@suhep.phy.syr.edu; **Michael Hack**, Xerox Palo Alto Research Center, (415) 812-4535, Fax (415) 493-6349, hack@parc.xerox.com; **Arun Madan**, MV Systems, Inc., (303) 526-9016, Fax (303) 526-1408; **Martin J. Powell**, Philips Research Laboratories, United Kingdom, (44) 293-815153, Fax (44) 293-815500, powell@prl.philips.co.uk; **Akihisa Matsuda**, Electrotechnical Laboratory, Japan, (81) 298-54-5252, Fax (81) 298-58-5425; **Administrative Contact: Mary Ann Woolf**, University of Utah, (801) 581-4246, Fax (801) 581-4246 or 4801, woolf@pclub.physics.utah.edu

### B: ADVANCED METALLIZATION FOR DEVICES AND CIRCUITS - SCIENCE, TECHNOLOGY, AND MANUFACTURABILITY - III

**Shyam P. Murarka**, Rensselaer Polytechnic Institute, (518) 276-2978, Fax (518) 276-8761; **Avishay Katz**, AT&T Bell Laboratories, (908) 582-2261, Fax (908) 582-4347; **K.N. Tu**, IBM T.J. Watson Research Center, (914) 945-1602, Fax (914) 945-2141; **Karen Maex**, IMEC, Belgium, (32) 16-28-1211, Fax (32) 16-28-1214

### C: MATERIALS RELIABILITY IN MICROELECTRONICS IV

**Peter E. Børgesen**, Cornell University, (607) 255-7218, Fax (607) 255-6575, alliance@msc.cornell.edu; **John E. Sanchez, Jr.**, Advanced Micro Devices, (408) 749-2169, Fax (408) 749-5144, john.sanchez@amd.com; **William Filter**, Sandia National Laboratories, (505) 844-3971, Fax (505) 844-2991; **Kenneth P. Rodbell**, IBM T.J. Watson Research Center, (914) 945-1012, Fax (914) 945-2141, rodbell@watson.ibm.com; **John C. Coburn**, E.I. DuPont Experimental Station, (302) 695-3413, Fax (302) 695-3813, coburn@esvax.denet.dupont.com

### D: DIAMOND, SiC AND NITRIDE WIDE-BANDGAP SEMICONDUCTORS

**Calvin H. Carter, Jr.**, Cree Research Inc., (919) 361-5709, Fax (919) 361-4630; **Shuji Nakamura**, Nichia Chemical Industries, Ltd., Japan, (81) 884-22-2311, Fax (81) 884-23-1802; **Gennady Gildenblat**, Pennsylvania State University, (814) 863-4256, Fax (814) 865-7065; **Robert J. Nemanich**, North Carolina State University, (919) 515-3225, Fax (919) 515-7331

### E: COMPOUND SEMICONDUCTOR EPITAXY

**Charles W. Tu**, University of California, San Diego, (619) 534-4687, Fax (619) 534-4687, ctu@ucsd.edu; **Leslie A. Kolodziejski**, Massachusetts Institute of Technology, (617) 253-6868, Fax (617) 258-6640, lak@mit.edu; **Victor R. McCrary**, AT&T Bell Laboratories, (908) 582-7470, Fax (908) 582-4053, vic@allwise.att.com

### F: EPITAXIAL OXIDE THIN FILMS AND HETEROSTRUCTURES

**R. Ramesh**, Bellcore, (908) 758-3126, Fax (908) 758-4372, ramesh1@troy.bellcore.com; **Julia M. Phillips**, AT&T Bell Laboratories, (908) 582-4428, Fax (908) 582-2521, jmp@allwise.att.com; **D.K. Fork**, Xerox PARC, (415) 812-4121, Fax (415) 812-4140, fork.parc@xerox.com; **R.M. Wolf**, Philips Research Laboratories, The Netherlands, (31) 40-743748, Fax (31) 40-743365, wolfr@prl.philips.nl

### G: RAPID THERMAL AND INTEGRATED PROCESSING III

**Jeffrey C. Gelpy**, Peak Systems, Inc., (508) 535-6997, Fax (508) 535-7079; **Martin L. Green**, AT&T Bell Laboratories, (908) 582-5310, Fax (908) 582-2699, mlg@physics.att.com; **Jimmie J. Wortman**, North Carolina State University, (919) 515-5255, Fax (919) 515-3027, jjw@eos.ncsu.edu; **Steven R.J. Brueck**, University of New Mexico, (505) 277-6033, Fax (505) 277-6433, brueck@chtm.eece.unm.edu

### H: POLYCRYSTALLINE THIN FILMS - STRUCTURE, TEXTURE, PROPERTIES AND APPLICATIONS

**Michael Parker**, IBM ADSTAR, (408) 256-4039, Fax (408) 256-5151, mparker@sjevm13.vnet.ibm.com; **Robert Sinclair**, Stanford University, (415) 723-1102, Fax (415) 725-4034; **Jerrold Floro**, Sandia National Laboratories, (505) 844-4708, Fax (505) 844-9185; **Katayun (Katy) Barmak**, Lehigh University, (215) 758-4218, Fax (215) 758-4244, kab6@lehigh.edu; **David A. Smith**, Stevens Institute of Technology, (201) 216-5306, Fax (201) 216-8306, mst\_dsmith@vaxc.stevens-tech.edu

### I: MATERIALS & PROCESSES FOR ENVIRONMENTAL PROTECTION

**Carol Adkins**, Sandia National Laboratories, (505) 845-9119, Fax (505) 844-2974, cladkin@somnet.sandia.gov; **L. Michael Quick**, Engelhard Corporation, (908) 205-5590, Fax (908) 321-0334; **Prasad N. Gadgil**, Simon Fraser University, Canada, (604) 291-4576, Fax (604) 291-4951, gadgil@cs.sfu.ca; **Kenneth E. Voss**, Engelhard Corporation, (908) 205-5146, Fax (908) 205-5300

### J: ENVIRONMENTAL SCIENCES

**Jan A.K. Paul**, The Royal Institute of Technology, Sweden, (46) 8-790-6169, Fax (46) 8-249-131; **Claire-Marie Pradier**, The Royal Institute of Technology, Sweden, (46) 8-790-7105, Fax (46) 8-249-131; **John L. Robbins**, Exxon Research and Engineering Company, (908) 730-3237, Fax (908) 730-3042; **Meyer Steinberg**, Brookhaven National Laboratory, (516) 282-3036, Fax (516) 282-3000

#### **K: LIQUID CRYSTAL POLYMERS**

**Shaw H. Chen**, University of Rochester, (716) 275-4040, Fax (716) 442-6686; **Heino Finkelmann**, Universität Freiburg, Germany, (49) 761-2034621, Fax (49) 761-276453; **Tisato Kajiyama**, Kyushu University, Japan, (81) 92-641-1101, Ext. 5601, 5602, Fax (81) 92-651-5606; **Stephen D. Jacobs**, University of Rochester, (716) 275-4837, Fax (716) 275-5960

#### **L: ELECTROLUMINESCENT POLYMERS**

**Nicholas F. Colaneri**, UNIAx Corporation, (805) 967-0578, Fax (805) 967-5383, 3015unax@ucsbuxa.ucsb.edu; **Donal D.C. Bradley**, University of Cambridge, United Kingdom, (44) 223-337315, Fax (44) 223-350266, ddcbl1@phx.cam.ac.uk

#### **M: FLAT PANEL DISPLAY MATERIALS**

**John Batey**, IBM T.J. Watson Research Center, (914) 681-5545, Fax (914) 681-5580; **Peter Bocko**, Corning, Inc., (607) 974-3854, Fax (607) 974-3675; **Anne Chiang**, Xerox Palo Alto Research Center, (415) 812-4524, Fax (415) 812-4502; **Paul Holloway**, University of Florida, (904) 392-6664, Fax (904) 392-4911

#### **N: BETTER CERAMICS THROUGH CHEMISTRY VI**

**Clément Sanchez**, Université Pierre et Marie Curie, France, (33) 331-4427-5545, Fax (33) 331-4427-4769; **Martha L. McCartney**, University of California, Irvine, (714) 725-2919, Fax (714) 856-8585; **C. Jeffrey Brinker**, Sandia National Laboratories, (505) 272-7627, Fax (505) 272-7304; **Anthony Cheetham**, University of California, Santa Barbara, (805) 893-8767, Fax (805) 893-8797

#### **O: MICROWAVE PROCESSING OF MATERIALS IV**

**Magdy F. Iskander**, University of Utah, (801) 581-6944, Fax (801) 581-5281, iskander@ee.utah.edu; **Robert J. Lauf**, Oak Ridge National Laboratory, (615) 574-5176, Fax (615) 576-8424; **Willard H. Sutton**, United Technologies Research Center, (203) 727-7639; Fax (203) 727-7879

#### **P: SCINTILLATOR AND PHOSPHOR MATERIALS**

**Marvin J. Weber**, Lawrence Livermore National Laboratory, (510) 423-1036, Fax (510) 422-3360; **Randal C. Ruchti**, University of Notre Dame, (219) 631-7143, Fax (219) 631-5952; **William M. Yen**, University of Georgia, (706) 542-2491, Fax (706) 542-2492; **Paul Lecoq**, Centre Européen pour le Recherche Nucléaire, Switzerland, (41) 22-767-6558, Fax (41) 22-782-7523; **Craig Woody**, Brookhaven National Laboratory, (516) 282-2752, Fax (516) 282-5568; **Ren-yuan Zhu**, California Institute of Technology, (818) 356-6661, Fax (818) 795-3951

#### **Q: MATERIALS IN MUSICAL INSTRUMENTS**

**Terry Garino**, Sandia National Laboratories, (505) 845-8762, Fax (505) 844-2974, tgarin@sandia.gov; **Delwin D. Fandrich**, Fandrich Piano Company, (206) 533-8053, Fax (206) 533-0820; **Harry Gatos**, Massachusetts Institute of Technology, (617) 253-5301, Fax (617) 891-6650; **David G. Monette**, David G. Monette Corporation, (503) 255-5552, Fax (503) 255-5593

#### **R: MATERIALS FOR SEPARATION TECHNOLOGY**

**Jerry Y.S. Lin**, University of Cincinnati, (513) 556-2769, Fax (513) 556-3473, jlin@alpha.che.uc.edu; **Paul N. Dyer**, Air Products and Chemicals, Inc., (215) 481-5778, Fax (215) 481-6517; **Carol Ashley**, Sandia National Laboratories, (505) 845-8931, Fax (505) 844-2974

#### **S: HIGH-TEMPERATURE SUPERCONDUCTORS - MULTILAYERS, INTERFACES, AND APPLICATIONS**

**Dean W. Face**, DuPont Central Research and Development, (302) 695-9227, Fax (302) 695-2721, faced@esvax.dnet.dupont.com; **C.T. Rogers**, University of Colorado, (303) 492-4476, Fax (303) 492-2998; **Dean Peterson**, Los Alamos National Laboratory, (505) 665-3030, Fax (505) 665-3164;

**Pradeep Haldar**, Intermagnetics General Corporation, (518) 456-5456, Fax (518) 456-0590

#### **T: NOVEL FORMS OF CARBON II**

**Clifford L. Renschler**, Sandia National Laboratories, (505) 844-0324, Fax (505) 844-9624; **John Pouch**, NASA Lewis Research Center, (216) 433-3523, Fax (216) 433-8705; **Donald Cox**, Exxon Research & Engineering Co., (908) 730-2726, Fax (908) 730-3344; **Yohji Achiba**, Tokyo Metropolitan University, Japan, (81) 426-77-2534, Fax (81) 426-77-2525

#### **U: INTERMETALLIC MATRIX COMPOSITES III**

**Jeffrey A. Graves**, Rockwell International Science Center, (805) 373-4438, Fax (805) 373-4775; **Randy R. Bowman**, NASA Lewis Research Center, (216) 433-3205, Fax (216) 433-8011; **John J. Lewandowski**, Case Western Reserve University, (216) 368-4234, Fax (216) 368-8618

#### **V: MOLECULARLY DESIGNED ULTRAFINE/ NANOSTRUCTURED MATERIALS**

**Kenneth E. Gonsalves**, University of Connecticut, (203) 486-6134, Fax (203) 486-4745; **Tongsan D. Xiao**, University of Connecticut, (203) 486-2503, Fax (203) 486-4745; **Gan-Moog Chow**, Naval Research Laboratory, (202) 404-7947, Fax (202) 767-1295, chow@anvil.nrl.navy.mil; **Robert C. Cammarata**, Johns Hopkins University, (410) 516-5462, Fax (410) 516-5293

#### **W: THEORY AND SIMULATION OF TIME-DEPENDENT PROCESSES IN MATERIALS**

**Michael Baskes**, Sandia National Laboratories, (510) 294-3226, Fax (510) 294-3410, baskes@ca.sandia.gov; **Sokrates Pantelides**, IBM T.J. Watson Research Center, (914) 945-1207, Fax (914) 945-2141, panteli@yktvmv.bitnet; **Alan Needleman**, Brown University, (401) 863-2863, Fax (401) 863-1157, needle@engin.brown.edu

#### **X: FRONTIERS OF MATERIALS RESEARCH**

**James M.E. Harper**, IBM T.J. Watson Research Center, **Alan J. Hurd**, Sandia National Laboratories, (505) 845-8629, Fax (505) 844-2974, ajhurd@somnet.sandia.gov; **James E. Mark**, University of Cincinnati, (513) 556-9292, Fax (513) 556-9239, jemark@ucbeh.san.uc.edu

For general meeting information, contact:



**MATERIALS RESEARCH SOCIETY**

9800 McKnight Road, Pittsburgh, PA 15237  
Fax (412) 367-4373

#### **MEETING CHAIRS**

**James M.E. Harper**, IBM T.J. Watson Research Center, Room 12-254, P.O. Box 218, Yorktown Heights, NY 10598, (914) 945-1663, Fax (914) 945-4015, harperj@watson.ibm.com

**Alan J. Hurd**, Department 1841, Sandia National Laboratories, P.O. Box 5800, Albuquerque, NM 87185-5800, (505) 845-8629, Fax (505) 844-2974, ajhurd@somnet.sandia.gov

**James E. Mark**, Department of Chemistry, University of Cincinnati, ML 172, Cincinnati, OH 45221-0172, (513) 556-9292, Fax (513) 556-9239, jemark@ucbeh.san.uc.edu